Measurement of transverse Emittance

The emittance characterizes the whole beam quality, assuming linear behavior as described by second order differential equation. 1

It is defined within the phase space as: $\varepsilon_x = \frac{1}{\pi} \int$ $\alpha_x = \frac{1}{\pi} \int_A dx dx'$ π ${\cal E}$

The measurement is based on determination of:

either profile width σ_x and angular width σ_x' at one location $or \sigma_x$ at different locations and linear transformations.

Different devices are used at transfer lines:

 \triangleright Lower energies E_{kin} < 100 MeV/u: slit-grid device, pepper-pot (suited in case of non-linear forces).

 All beams: Quadrupole variation, 'three grid' method using linear transformations (**not** well suited in the presence of non-linear forces)

Synchrotron: lattice functions results in stability criterion

$$
\Rightarrow \text{beam width delivers emittance:} \quad \varepsilon_x = \frac{1}{\beta_x(s)} \left[\sigma_x^2 - \left(D(s) \frac{\Delta p}{p} \right) \right] \text{ and } \quad \varepsilon_y = \frac{\sigma_y^2}{\beta_y(s)}
$$

Definition of transverse Emittance

 $\begin{array}{c} \end{array}$ \int

'

x

x

 $\overline{}$ \setminus

Angle

with $x =$

 \rightarrow

 \int

 X' $\begin{bmatrix} x'_{\sigma} = (\sigma_{22})^{1/2} \\ = (\epsilon \gamma)^{1/2} \end{bmatrix}$

-

Area:
A= $\pi\epsilon$

 $\bigg)$

A $\alpha_x = \frac{1}{x} \int dx dx'$

 $\frac{1}{\sqrt{2}}$

 $=\frac{1}{\pi}$

 π

1

 α γ

 β $-\alpha$

 $\bigg($

 $\left.\rule{0pt}{10pt}\right)$

Ansatz: Beam matrix at one location: It describes a 2-dim probability distr. $\overline{}$ \setminus $\bigg($ $\Big| = \varepsilon$. \int $\left.\rule{0pt}{10pt}\right.$ $\overline{}$ \setminus $\bigg($ $=$ $\begin{pmatrix} 11 & 0 & 12 \\ 12 & \sigma_{22} \end{pmatrix} = \varepsilon \cdot \begin{pmatrix} \rho & -\alpha \\ -\alpha & \gamma \end{pmatrix}$ with x $\frac{1}{11}$ σ_{12} ${\cal E}$ σ_{12} σ $\boldsymbol{\sigma} = \begin{bmatrix} \sigma_{11} & \sigma_{12} & \sigma_{13} & \sigma_{24} & \sigma_{25} & \sigma_{26} & \sigma_{27} & \sigma_{2$ The emittance characterizes the whole beam quality: $\mathcal E$

The value of emittance is:

$$
\varepsilon_x = \sqrt{\det \sigma} = \sqrt{\sigma_{11} \sigma_{22} - \sigma_{12}^2}
$$

For the profile and angular measurement:

$$
x_{\sigma} = \sqrt{\sigma_{11}} = \sqrt{\epsilon \beta} \text{ and}
$$

\n
$$
x'_{\sigma} = \sqrt{\sigma_{22}} = \sqrt{\epsilon \gamma}
$$

\nGeometrical interpretation:
\nAll points **x** fulfilling $x^t \cdot \sigma^{-1} \cdot x = 1$
\nare located on a ellipse
\n
$$
\sigma_{22}x^2 - 2\sigma_{12}xx' + \sigma_{11}x'^2 = \det \sigma = \epsilon_x^2
$$
\n
$$
x_{\sigma} = (\sigma_{11})^{1/2}
$$
\n
$$
y_{\sigma} = (\sigma_{11})^{1/2
$$

The Emittance for Gaussian Beams

The density function for a 2-dim Gaussian distribution is:

$$
\rho(x, x') = \frac{1}{2\pi\epsilon} \exp\left[-\frac{1}{2} \vec{x}^T \ \sigma^{-1} \ \vec{x}\right]
$$

$$
= \frac{1}{2\pi\epsilon} \exp\left[\frac{-1}{2\det\sigma} \left(\sigma_{22}x^2 - 2\sigma_{12}xx' + \sigma_{11}x'^2\right)\right]
$$

It describes an ellipse with the characteristics profile and angle Gaussian distribution of width

$$
x_{\sigma} \equiv \sqrt{\langle x^2 \rangle} = \sqrt{\sigma_{11}} \text{ and}
$$

$$
x_{\sigma}' \equiv \sqrt{\langle x'^2 \rangle} = \sqrt{\sigma_{22}}
$$

and the correlation or covariance

$$
cov \equiv \sqrt{\langle xx' \rangle} = \sqrt{\sigma_{12}}
$$

For
$$
\mathbf{A} = \begin{pmatrix} a & b \\ c & d \end{pmatrix}
$$
 it is $\mathbf{A}^{-1} = \frac{1}{ad - bc} \begin{pmatrix} d & -b \\ -c & a \end{pmatrix}$

assuming $\det(A) = ad-bc \neq 0 \Leftrightarrow$ matrix invertible $\int_{a}^{b} p \cdot a \cdot dA$ $\int_{c}^{b} f(a) \cdot dA$

The Emittance for Gaussian and non-Gaussian Beams

The beam distribution can be non-Gaussian, e.g. at:

 \triangleright beams behind ion source

 \mathbf{r}

- \triangleright space charged dominated beams at LINAC & synchrotron
- \triangleright cooled beams in storage rings

General description of emittance using terms of 2-dim distribution:

It describes the value for 1 stand. derivation

 $2\sqrt{x^2}\sqrt{x^2}$ $\mathcal{E}_{rms} = \sqrt{\langle x^2 \rangle \langle x'^2 \rangle} \frac{1}{\sqrt{x^2}}$ $=\left(\frac{\langle x^2 \rangle \langle x^2 \rangle}{\gamma^2}\right)$ **Variances i.e. correlation**

For discrete distribution:

Covariance

$$
\langle x \rangle = \mu = \frac{\int \int x \cdot \rho(x, x') dx dx'}{\int \int \rho(x, x') dx dx'}
$$

$$
\langle x' \rangle = \mu' = \frac{\int \int x' \cdot \rho(x, x') dx dx'}{\int \int \rho(x, x') dx dx'}
$$

$$
\langle x'' \rangle = \frac{\int \int (x - \mu)^n \cdot \rho(x, x') dx dx'}{\int \int \rho(x, x') dx dx'} \qquad \langle x'' \rangle = \frac{\int \int (x' - \mu')^n \cdot \rho(x, x') dx dx'}{\int \int \rho(x, x') dx dx'}
$$

$$
\text{covariance: } \langle xx' \rangle = \frac{\int \int (x - \mu)(x' - \mu') \cdot \rho(x, x') dx dx'}{\int \int \rho(x, x') dx dx'} \qquad \text{and}
$$

$$
\langle x \rangle = \frac{\sum_{i,j} \rho(i,j) \cdot x_i x^i{}_j}{\sum_{i,j} \rho(i,j)}
$$

correspondingly for other moments

The Emittance for Gaussian and non-Gaussian Beams

The beam distribution can be non-Gaussian, e.g. at:

- \triangleright beams behind ion source
- \triangleright space charged dominated beams at LINAC & synchrotron
- \triangleright cooled beams in storage rings

General description of emittance

using terms of 2-dim distribution:

It describes the value for 1 stand. derivation

For Gaussian beams only:

 $\varepsilon_{rms} \leftrightarrow$ interpreted as area containing a fraction *f* of ions: $\varepsilon(f) = -2\pi\varepsilon_{rms} \cdot \ln(1-f)$

factor to ϵ_{rms}	$1 \cdot \epsilon_{rms}$	$\pi \cdot \epsilon_{rms}$	$2\pi \cdot \epsilon_{rms}$	$4\pi \cdot \epsilon_{rms}$	$6\pi \cdot \epsilon_{rms}$	$8\pi \cdot \epsilon_{rms}$	
factor to ϵ_{rms}	$\left[\%\right]$	15	39	63	86	95	98

Care: no common definition of emittance concerning the fraction *f*

Covariance

i.e. correlation

 $2\sqrt{x^2}\sqrt{x^2}$

Variances

 $\mathcal{E}_{rms} = \sqrt{\langle x^2 \rangle \langle x'^2 \rangle} \frac{1}{\sqrt{x^2}}$ $=\left(\frac{\langle x^2 \rangle \langle x^2 \rangle}{\gamma^2}\right)$

Outline:

- **Definition and some properties of transverse emittance**
- **Slit-Grid device: scanning method**

scanning slit \rightarrow **beam position & grid** \rightarrow **angular distribution**

- **Pepper-pot device: single shot device**
- **Quadrupole strength variation and position measurement**
- **Summary**

The Slit-Grid Measurement Device

Slit: position *P(x)* with typical width: 0.1 to 0.5 mm *Distance:* 10 cm to 1 m (depending on beam velocity) *SEM-Grid:* angle distribution *P(x′)*

Slit & SEM-Grid

Slit with e.g. 0.1 mm thickness → Transmission only from Δx .

Example: Slit of width 0.1 mm (defect) Moved by stepping motor, 0.1 mm resolution

Beam surface interaction: e[−] emission \rightarrow measurement of current. *Example: 15 wire spaced by 1.5 mm:*

Each wire is equipped with one I/U converter different ranges settings by *Rⁱ* \rightarrow very large dynamic range up to 10⁶.

Display of Measurement Results

- Finite **binning** results in limited resolution
- \triangleright **Background** \rightarrow large influence on $\langle x^2 \rangle$, $\langle x^2 \rangle$ and $\langle xx' \rangle$
- **Or fit of distribution i.e. ellipse to data**
- **Effective emittance only**

Beam: Ar4+, 60 KeV, 15 μA at Spiral2 Phoenix ECR source.

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The Resolution of a Slit-Grid Device

The width of the slit d_{slit} gives the resolution in space $\Delta x = d_{slit}$. The angle resolution is $\Delta x' = (d_{wire} + 2r_{wire})/d$

 \Rightarrow discretization element Δx **・** $\Delta x'$.

By scanning the SEM-grid the angle resolution can be improved.

Problems for small beam sizes or parallel beams.

For pulsed LINACs: Only one measurement each pulse \rightarrow long measuring time required.

Result of an Slit-Grid Emittance Measurement

Result for a beam behind ion source: \triangleright here aberration in quadrupoles due to large beam size

Low energy ion beam: \rightarrow well suited for emittance showing space-charge effects or aberrations.

\triangleright different evaluation and plots possible

 \triangleright can monitor any distribution

Transverse Emittance Measurement

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The Noise Influence for Emittance Determination

Let Γ or ch, 30 A decreasing proton acceleration acceleration and proton acceleration for p-physics at the future GSI facilities at

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Outline:

- **Definition and some properties of transverse emittance**
- **Slit-Grid device: scanning method scanning slit** \rightarrow **beam position & grid** \rightarrow **angular distribution**
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	- hole-plate \rightarrow beam position $\&$ screen \rightarrow angular distribution
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- **Summary**

The Pepperpot Emittance Device

 For pulsed LINAC: Measurement within one pulse is an advantage \triangleright If horizontal and vertical direction coupled \rightarrow 2-dim evaluation **required**

Good **spatial** resolution if many holes are illuminated. Good **angle** resolution *only* if spots do not overlap.

Partly from H.R. Kremers et al., ECRIS 2010

 y'_3

 y_3

y as [mm]

The Pepperpot Emittance Device at GSI UNILAC

Result of a Pepperpot Emittance Measurement

*Example***:** Ar $1+$ ion beam at 1.4 MeV/u, screen image from single shot at GSI:

Data analysis: Projection on horizontal and vertical plane \rightarrow analog to slit-grid.

Transverse Emittance Measurement

30

25

10

 \overline{a}

The Artist View of a Pepperpot Emittance Device

Outline:

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- **Pepper-pot device: single shot device** hole-plate \rightarrow beam position $\&$ screen \rightarrow angular distribution
- **Quadrupole strength variation and position measurement emittance from several profile measurement and beam optical calculation Summary**

Excurse: Particle Trajectory and Characterization of many Particles

Let Torch, 30A3 Archamps GSI-Palace proton accelerator for p-physics at the future GSI facilities at the futur

Excurse: Definition of Offset and Divergence

Horizontal and vertical coordinates at *s = 0* **:**

- **▶** *x* **:** Offset from reference orbit in [mm]
- *★ x'***:** Angle of trajectory in unit [mrad]

x' = dx / ds

Assumption: par-axial beams:

- \triangleright *x* is small compared to ρ_0
- \triangleright Small angle with p_x / p_s << 1
- **Longitudinal coordinate:**
- ≻ Longitudinal orbit difference: $\mathbf{l} = -v_0 \cdot (\mathbf{t} \mathbf{t}_0)$ in unit [mm]
- \triangleright Momentum deviation: $\delta = (p p_0) / p_0$ sometimes in unit [mrad] = [‰]

For **continuous** beam: *l* has no meaning \Rightarrow set $l = 0$!

Reference particle: no horizontal and vertical offset $x \equiv y \equiv 0$ and $l \equiv 0$ for all *s*

x $\frac{1}{x}$

l

x

s

Excurse: Definition of Coordinates

GST

Excurse: Some Properties of the Transfer Matrix

 \triangleright The transformation can be done successive: with

with
$$
\mathbf{R}_I = \mathbf{R}(s_0 \rightarrow s_1)
$$
,..., $\mathbf{R}_n = \mathbf{R}(s_{n-1} \rightarrow s_n)$
It is $\mathbf{R} = \mathbf{R}_n \cdot \mathbf{R}_{n-1} \cdot ... \cdot \mathbf{R}_I$

 \triangleright The elements describe the coupling between the components

*R*₁₁ = (x | x), R₁₂ = (x | x'), R₁₃ = (x | y), R₁₄ = (x | y'), R₁₅ = (x | l), R₁₆ = (x | δ)…. > If all forces are symmetric along the reference orbit than the horizontal and vertical plane are decoupled: \Rightarrow sub-matrix is sufficient It is $det(R) = 1$ (Liouville's Theorem) i.e. **R** is invertible \triangleright Sub-matrix here shown for drift *L*: I \cdot I $\overline{}$ $\overline{}$ $\overline{}$ $\overline{}$ $\overline{}$ IJ \setminus $\overline{}$ $\overline{}$ \vert $\begin{array}{c} \end{array}$ $\begin{array}{c} \end{array}$ |
| l I $\begin{pmatrix} 0 & 0 & 0 & 0 \end{pmatrix}$ ſ $R =$ $(l | x)$ $(l | x')$ $\overline{0}$ $\overline{0}$ 1 $(l | l)$ 0 0 $(y'|y)$ $(y'|y') = 0$ 0 0 0 $(y|y)$ $(y|y') = 0$ 0 $(x'| x) (x'| x')$ 0 0 $(x'| \delta)$ $(x | x) (x | x')$ 0 0 $(x | \delta)$ $l | x$ $(l | x')$ $\overline{0}$ $\overline{0}$ l $(l | l)$ *y y y y y y y y* $y | y) (y | y)$ $x'|x)$ $(x'|x')$ 0 0 0 $(x$ $x | x$ $(x | x')$ 0 0 $(x | x')$ δ δ 0 1 1 $R_{x} = \begin{pmatrix} 1 & L \\ 0 & 1 \end{pmatrix}$ \int $\left.\rule{0pt}{10pt}\right)$ $\overline{}$ $\overline{}$ \setminus $\bigg($ $=$ *L* $\mathbf{x} = \begin{bmatrix} 0 & 1 \end{bmatrix}$ $\mathbf{x} = \begin{bmatrix} 0 & 1 \end{bmatrix}$ $\mathbf{y} = \begin{bmatrix} 0 & 1 \end{bmatrix}$ $\overline{}$ \int $\left.\rule{0pt}{10pt}\right)$ $\overline{}$ $\overline{}$ \setminus $\bigg($ $=$ 0 1 1 $L/$ R L/γ^2 $0 \quad 1 \leq l \leq s$ 1 $R_y = \begin{pmatrix} 1 & L \\ 0 & 1 \end{pmatrix}$ \int $\left.\rule{0pt}{10pt}\right.$ $\overline{}$ $\overline{}$ \setminus $\bigg($ $=$ *L y*

Peter Forck, JUAS Archamps 6003 GSI-Palaver, 2003, A dedicated proton accelerator for proton and future GSI facilities at the future GS

Transverse Emittance Measurement

Liouville's Theorem:

The phase space density can not changes with conservative e.g. linear forces.

The beam distribution at one location s_{θ} is described by the beam matrix $\sigma(s_{\theta})$

This beam matrix is transported from location s_0 to s_1 via the transfer matrix

$$
\sigma(s_1) = \mathbf{R} \cdot \sigma(s_0) \cdot \mathbf{R}^T
$$

6-dim beam matrix with *decoupled* **horizontal and vertical plane:**

$$
\sigma = \begin{pmatrix}\n\sigma_{11} & \sigma_{12} & 0 & 0 & \sigma_{15} & \sigma_{16} \\
\sigma_{12} & \sigma_{22} & 0 & 0 & \sigma_{25} & \sigma_{26} \\
0 & 0 & \sigma_{33} & \sigma_{34} & 0 & 0 \\
0 & 0 & \sigma_{34} & \sigma_{44} & 0 & 0 \\
\sigma_{15} & \sigma_{25} & 0 & 0 & \sigma_{55} & \sigma_{56} \\
\sigma_{16} & \sigma_{26} & 0 & 0 & \sigma_{56} & \sigma_{66}\n\end{pmatrix}
$$
\n
$$
\begin{array}{c}\n\text{Horizontal} & \text{Beam width for} \\
\text{beam matrix:} & \text{the three coordinates:} \\
\sigma_{11} = \langle x^2 \rangle & x_{\text{rms}} = \sqrt{\langle x^2 \rangle} = \sqrt{\sigma_{11}} \\
y_{\text{rms}} = \sqrt{\langle y^2 \rangle} = \sqrt{\sigma_{33}} \\
l_{\text{rms}} = \sqrt{\langle l^2 \rangle} = \sqrt{\sigma_{55}} \\
\end{array}
$$

Excurse: Some Examples for linear Transformations

The 2-dim sub-space (x, x') can be used in case there is coupling like dispersion $R_{16} = (x / \delta) = 0$ **Important examples are:**

- \triangleright Drift with length *L*: $\mathbf{R}_{\text{drift}} =$ 1 0 1
- Horizontal **focusing** with quadrupole constant *k* end effective length *l*:

$$
\mathbf{R}_{\text{focus}} = \begin{pmatrix} \cos \sqrt{k} \, l & \frac{1}{\sqrt{k}} \sin \sqrt{k} \, l \\ -\sqrt{k} \cdot \sin \sqrt{k} \, l & \cos \sqrt{k} \, l \end{pmatrix} \Rightarrow \mathbf{R}_{\text{focus}}^{\text{thin lens}} = \begin{pmatrix} 1 & 0 \\ -1/f & 1 \end{pmatrix}
$$

Horizontal **de-focusing** with quadrupole constant *k* end effective length *l*:

$$
\mathbf{R}_{\text{de-focus}} = \begin{pmatrix} \cosh \sqrt{k} \, l & \frac{1}{\sqrt{k}} \sinh \sqrt{k} \, l \\ \sqrt{k} \cdot \sinh \sqrt{k} \, l & \cosh \sqrt{k} \, l \end{pmatrix} \qquad \Rightarrow \quad \mathbf{R}_{\text{de-focus}}^{\text{thin lens}} = \begin{pmatrix} 1 & 0 \\ 1/f & 1 \end{pmatrix}
$$

Ideal quad.: field gradient $g = B_{pole}/a$, B_{pole} field at poles, *a* aperture \rightarrow quadrupole constant $\mathbf{k} = \frac{\rho g}{\rho_0}$ *s* **Horizontal focusing:** Δ*x' f*

Thin lens approximation: $l \to 0 \Rightarrow kl \to \text{const} \Rightarrow kl \equiv 1/f$

 \Rightarrow simple transfer matrix (math. proof by 1st order Taylor expansion) \qquad Kick: $\Delta x' = -x/f$

Emittance Measurement by Quadrupole Variation

From a profile determination, the emittance can be calculated via linear transformation, if a well known and constant distribution (e.g. Gaussian) is assumed. quadrupole magnet profile measurement focusing const. k $(e.g. SEM grid)$ transverse beam envelope beam path s The beam width *xmax* and $R(k)$ $S₁$ $S_{\rm o}$ location: linear transformation $x^2_{max} = \sigma_{II}(1, k)$ is measured, phase space phase space $\bar{\mathbf{x}}$ $\bar{\ast}$ matrix **R(k)** describes the focusing.divergence divergence profile coordinate x measurement: profile beam matrix: ${\bf x}^2({\bf k}) = \sigma_{11}(1,{\bf k})$ (Twiss parameters) $\sigma_{11}(0), \sigma_{12}(0), \sigma_{22}(0)$ to be determined coordinate x

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Transverse Emittance Measurement

- The beam width x_{max} at s_1 is measured, and therefore $\sigma_{11}(1, k_i) = x_{max}^2(k_i)$.
- Different focusing of the quadrupole $k_1, k_2...k_n$ is used: \Rightarrow $\mathbf{R}_{\text{focus}}(k_i)$, including the drift, the transfer matrix is changed $\mathbf{R}(k_i) = \mathbf{R}_{\text{drift}} \cdot \mathbf{R}_{\text{focus}}(k_i)$.
- Task: Calculation of beam matrix $\sigma(0)$ at entrance s_0 (size and orientation of ellipse)
- The transformations of the beam matrix are: $\sigma(1,k) = \mathbf{R}(k) \cdot \sigma(0) \cdot \mathbf{R}^{T}(k)$. \Rightarrow Resulting in a redundant system of linear equations for $\sigma_{ij}(0)$:

$$
\sigma_{11}(1,k_1) = R_{11}^2(k_1) \cdot \sigma_{11}(0) + 2R_{11}(k_1)R_{12}(k_1) \cdot \sigma_{12}(0) + R_{12}^2(k_1) \cdot \sigma_{22}(0) \text{ focusing } k_1
$$

 $\sigma_{11}(1,k_n) = R_{11}^2(k_n) \cdot \sigma_{11}(0) + 2R_{11}(k_n)R_{12}(k_n) \cdot \sigma_{12}(0) + R_{12}^2(k_n) \cdot \sigma_{22}(0)$ focusing k_n

- To learn something on possible errors, $n > 3$ settings have to be performed. A setting with a focus close to the SEM-grid should be included to do a good fit.
- \bullet Assumptions:
	- Only elliptical shaped emittance can be obtained.
	- No broadening of the emittance e.g. due to space-charge forces.
	- If not valid: A self-consistent algorithm has to be used.

Measurement of transverse Emittance

Using the 'thin lens approximation' i.e. the quadrupole has a focal length of *f*:

Measurement of transverse Emittance
\nUsing the 'thin lens approximation' i.e. the quadrupole has a focal length of f:
\n
$$
R_{focus}(K) = \begin{pmatrix} 1 & 0 \\ -1/f & 1 \end{pmatrix} \equiv \begin{pmatrix} 1 & 0 \\ K & 1 \end{pmatrix} \Rightarrow R(L, K) = R_{drift}(L) \cdot R_{focus}(K) = \begin{pmatrix} 1 + LK & L \\ K & 1 \end{pmatrix}
$$
\n
$$
Mosevrement of $\sigma(L, K) = P(K) \cdot \sigma(0) \cdot P(T/K)$
$$

Example: Square of the beam width at ELETTRA 100 MeV e**-** Linac, YAG:Ce:

Measurement of *(1,K) =* **R***(K)∙(0)∙***R^T***(K)* $\sigma_{11}(1, K) = L^2 \sigma_{11}(0) \cdot K^2$

+2
$$
\cdot
$$
($L\sigma_{11}(0) + L^2\sigma_{12}(0)$) $\cdot K$
+ $L^2\sigma_{22}(0) + \sigma_{11}(0)$
= $a \cdot K^2 - 2ab \cdot K + ab^2 + c$

The σ -matrix at quadrupole is: $\sigma_{11}(0) = \frac{a}{l^2}$ $\sigma_{12}(0) = -\frac{a}{L^2} \left(\frac{1}{L} + b \right)$ $\sigma_{22}(0) = \frac{1}{L^2} \left(ab^2 + c + \frac{2ab}{L} + \frac{a}{L^2} \right)$ $\epsilon = \sqrt{\det \sigma(0)} = \sqrt{\sigma_{11}(0)\sigma_{22}(0) - \sigma_{12}^2(0)} = \sqrt{ac}/L^2$

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The 'Three Grid Method' for Emittance Measurement

Solution: Solving the linear equations like for quadrupole variation or fitting the profiles with linear optics code (e.g. TRANSPORT, WinAgile, MadX).

Emittance measurements are very important for comparison to theory.

It includes size (value of ε) and orientation in phase space (σ_{ij} or α , β and γ)

(three independent values)

Techniques for transfer lines (synchrotron: width measurement sufficient):

Low energy beams → direct measurement of x- and x′-distribution

- \triangleright *Slit-grid:* movable slit \rightarrow *x*-profile, grid \rightarrow *x'*-profile
- \triangleright *Pepper-pot*: holes \rightarrow *x*-profile, scintillation screen \rightarrow *x'*-profile

All beams → profile measurement + linear transformation:

Quadrupole variation: one location, different setting of a quadrupole

'Three grid method': different locations

 \triangleright Assumptions: \triangleright well aligned beam, no steering

 \triangleright no emittance blow-up due to space charge.